

Synchrotron Radiation to study Atomic Layer Deposition

Monday, 13 June 2016

Talks 2 (16:00 - 18:20)

time	[id] title	presenter
16:00	[30] Gas-source MBE growth of 2D materials examined using synchrotron radiation	Dr ENGSTROM, James
16:20	[28] Speciation depth-profiling of nano-structured specimen by combined GIXRF-NEXAFS	Dr POLLAKOWSKI, Beatrix
16:40	[12] Production and tailoring of etched ion-track nanopores and nanotubes by ALD	Dr CARRILLO SOLANO, Mercedes
17:00	Coffee break	
17:20	[8] Bulk Heterojunction Electrodes Based on CNT fibre/ZnO Hybrids Produced by ALD	Mr MONREAL, Alfonso
17:40	[3] Investigation of Si-doped HfO ₂ ALD films by means of EXAFS and XANES	Mr SCHENK, Tony
18:00	[2] SAXS Investigation of Nano-Pore Membranes Coated By Atomic Layer Deposition	Ms HADLEY, Andrea